

Our Docket No: 42P11369

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Fred Chen, et al.

Examiner: Rosasco, Stephen D.

Serial No: 10/040,772

Art Unit: 1756

Filed: January 4, 2002

For: An Active Secondary Exposure )  
Mask To Manufacture Integrated )  
Circuits )

PRELIMINARY AMENDMENTS

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Prior to examination of the present application, please enter the following amendments and consider the following remarks.

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that I am causing the above-referenced correspondence to be deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and that this paper or fee has been addressed to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450

October 22, 2004

Date of Deposit

Krista Mathieson

Name of Person Mailing Correspondence

Krista Mathieson

Signature

October 22, 2004

Date